

**Claim Amendments:**

This listing of claims will replace all prior versions, and listings, of claims in the application:

Claims 1-39 (Canceled).

40. (Newly added) A ceramic component, comprising:  
a ceramic body comprising silicon carbide and an oxide layer, said oxide layer being formed by oxidizing the ceramic body in the presence of alumina having a submicron particle size.

41. (Newly added) The ceramic component of claim 40, wherein the ceramic body comprises nitride bonded silicon carbide.

42. (Newly added) The ceramic component of claim 41, wherein the ceramic body comprises silicon carbide as a primary component, and silicon nitride as a secondary component.

43. (Newly added) The ceramic component of claim 42, wherein the ceramic body comprises about 5 to about 35 wt% silicon nitride.

44. (Newly added) The ceramic component of claim 41, wherein the ceramic body has a porosity within a range of about 5 to about 25 vol%.

45. (Newly added) The ceramic component of claim 41, wherein the ceramic body is formed by reacting a green body with nitrogen while heating, the green body containing silicon carbide and silicon.

46. (Newly added) The ceramic component of claim 45, wherein the green body is formed by slip casting a slurry containing silicon carbide and silicon, forming a cast, and drying the cast.

47. (Newly added) The ceramic component of claim 40, wherein the ceramic component is a refractory component.

48. (Newly added) The ceramic component of claim 47, wherein the refractory component is selected from a group consisting of support posts, support beams, support plates, and containers.

49. (Newly added) The ceramic component of claim 40, wherein the oxide layer comprises silica and at least one of alumina and an aluminosilicate.

50. (Newly added) The ceramic component of claim 49, wherein the oxide layer includes an aluminosilicate, said aluminosilicate comprising mullite, said mullite having a composition  $3\text{Al}_2\text{O}_3 \cdot 2\text{SiO}_2$ .

51. (Newly added) The ceramic component of claim 40, wherein the alumina has a particle size less than about 0.8 microns.

52. (Newly added) The ceramic component of claim 40, wherein the alumina has a particle size less than about 0.5 microns.

53. (Newly added) The ceramic component of claim 40, wherein the oxide layer is a surface layer.

54. (Newly added) A ceramic component, comprising:  
a ceramic body comprising silicon carbide and an oxide layer, said oxide layer being formed by oxidizing the ceramic body in the presence of alumina, the oxide layer containing an amorphous phase and a crystalline phase, the crystalline phase comprising anisotropically-shaped crystals.

55. (Newly added) The ceramic component of claim 54, wherein the anisotropically-shaped crystals comprise at least one of alumina and an aluminosilicate.

56. (Newly added) The ceramic component of claim 54, wherein the anisotropically-shaped crystals comprise at least one of alumina and mullite.

57. (Newly added) The ceramic component of claim 54, wherein the anisotropically-shaped crystals have an aspect ratio not less than about 3:1.

58. (Newly added) The ceramic component of claim 54, wherein the anisotropically-shaped crystals have an aspect ratio not less than about 5:1.

59. (Newly added) The ceramic component of claim 54, wherein the anisotropically-shaped crystals have a crystal size within a range of about 0.2 to about 20 microns.

60. (Newly added) The ceramic component of claim 54, wherein the anisotropically-shaped crystals have a crystal size within a range of about 0.5 to about 10 microns.

61. (Newly added) The ceramic component of claim 54, wherein the amorphous phase comprises silica and about 10 wt% to about 50 wt% alumina.

62. (Newly added) The ceramic component of claim 61, wherein the amorphous phase comprises at least about 12 wt% alumina.

63. (Newly added) The ceramic component of claim 54, wherein the oxide layer is a surface layer.

64. (Newly added) A ceramic component, comprising:  
a ceramic body comprising silicon carbide and an oxide layer, said oxide layer containing an amorphous phase and a crystalline phase, the crystalline phase comprising anisotropically-shaped crystals formed of at least one of alumina and an aluminosilicate.

65. (Newly added) A ceramic component, comprising:

a nitride bonded silicon carbide body having a porosity within a range of about 5 to about 25 vol%; and

an alumina-rich oxide layer, said oxide layer being formed by oxidizing the ceramic body, the oxide layer having an amorphous phase and a crystalline phase, the alumina rich oxide layer having not less than 5wt% more alumina than an alumina content in the nitride bonded silicon carbide body.

66. (Newly added) The ceramic component of claim 65, wherein the alumina rich oxide layer has not less than 7 wt% more alumina than an alumina content in the nitride bonded silicon carbide body.

67. (Newly added) The ceramic component of claim 65, wherein the alumina rich oxide layer is a surface layer.

68. (Newly added) A ceramic component, comprising:

a nitride bonded silicon carbide body having a porosity within a range of about 5 to about 25 vol%; and

an oxide layer, said oxide layer being formed by oxidizing the ceramic body in the presence of alumina, the oxide layer containing an amorphous phase, the amorphous phase comprising silica and about 10 wt% to about 50 wt% alumina.

69. (Newly added) The ceramic component of claim 68, wherein the amorphous phase comprises not less than about 12 wt% alumina.

70. (Newly added) The ceramic component of claim 68, wherein the amorphous phase comprises not greater than about 25 wt% alumina.

71. (Newly added) A method of forming a ceramic component, comprising:  
providing a ceramic body comprising silicon carbide;  
providing alumina in contact with the ceramic body, the alumina having a particle size  
less than 1.0 micron; and  
oxidizing the ceramic body.

72. (Newly added) The method of claim 71, wherein the step of providing the ceramic  
body is carried out by slip casting to form a cast, and drying the cast.

73. (Newly added) The method of claim 72, wherein the cast comprises silicon carbide  
and silicon, and the step of providing further includes subjecting the cast to a heat treatment step  
in which the cast is subjected to a nitrogen source, the ceramic body further comprising silicon  
nitride.

74. (Newly added) The method of claim 71, wherein the ceramic body is provided by  
subjecting a green body containing silicon nitride and silicon to a nitrogen source while heating  
the green body to a temperature greater than about 1300°C for a time period of at least 12 hours.

75. (Newly added) The method of claim 71, wherein the alumina is coated by one of  
dipping and spraying, the alumina being provided in a suspension.

76. (Newly added) A method of processing ceramic parts, comprising:  
providing ceramic parts and at least one refractory component in a furnace, the refractory  
component comprising a ceramic body comprising silicon carbide, and an oxide  
layer, the oxide layer being formed by oxidizing the ceramic body in the presence  
of alumina having a submicron particle size; and  
heat treating the ceramic parts and the at least one refractory component at a temperature  
not greater than 1500°C and for a time period not less than about 1 hour.

77. (Newly added) The method of claim 76, wherein said temperature is not greater than  
about 1400°C.

78. (Newly added) The method of claim 76, wherein said temperature is not greater than about 1300°C and said time period is not less than about 4 hours.

79. (Newly added) The method of claim 76, wherein the refractory component comprises kiln furniture for supporting the ceramic parts.

80. (Newly added) The method of claim 79, wherein the kiln furniture is a structural element selected from the group consisting of support posts, support beams, support plates, and containers.

81. (Newly added) The method of claim 76, wherein the refractory component comprises at least one of a structural wall of the furnace and a furnace liner.